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OFGS File No: P/727-116

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

LIN, Francis et al

New York, New York

Date: October 11, 2005

Serial No.: 10/680,311

Group Art Unit: 2632

Date Filed: October 7, 2003

For: METHOD FOR IMAGING A SEMICONDUCTOR WAFER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS INQUIRY LETTER

Sir:

We filed the above application with the U. S. Patent and Trademark Office on October 7, 2003.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully Submitted,

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